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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Takahiro OGUCHI

Date: April 13, 2000

Serial No.: To Be Assigned

Group Art Unit: ---

Filed: Herewith

Examiner: ---

For: **METHOD OF MANUFACTURING AN EXTERNAL FORCE DETECTION SENSOR**

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Assistant Commissioner for Patents  
Washington, D.C. 20231

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INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

EXPRESS MAIL CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Post Office to Addressee (mail label #EL157099597US) in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on April 13, 2000:

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Enclosures

Respectfully submitted,

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